



image =

PATENT 1762  
83373.0002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Franklin W. Dabby, et al.

Serial No: 09/894,447

Filed: June 28, 2001

For: PARTICLE DEPOSITION SYSTEM  
AND METHOD

Art Unit: 1762

Confirmation No.: 5193

Examiner: Not Assigned

**THIRD STATUS REQUEST**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
September 22, 2003  
Date of Deposit  
Ying Chen, Reg. No. 50,193  
Name  
Signature 9/22/03 Date


The above-referenced application was filed on June 28, 2001 and a second status request was filed on March 5, 2003. A status reply was received from the Patent Office indicating the application would be examined by August 19, 2003. To date, no further papers have been received in this case.

Please send the undersigned a Status Report on this application.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: September 22, 2003

By:   
Ying Chen  
Registration No. 50,193  
Attorney for Applicant(s)

500 South Grand Avenue, Suite 1900  
Los Angeles, California 90071  
Phone: 213-337-6700  
Fax: 213-337-6701